



*B. Baw*

## PATENT APPLICATION

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Docket No: 005651 USA Y 01/ETCH/CHMBR/JB1  
Michael Barnes, et al. Allowed: July 1, 2004  
Appln. No.: 09/834,343 Group Art Unit: 1763  
Confirmation No.: 2414 Examiner: A. Crowell  
Filed: April 12, 2001

For: PLASMA REACTOR ELECTRODE

### SUBMISSION OF DRAWINGS

#### MAIL STOP ISSUE FEE

#### ATTN: OFFICIAL DRAFTSPERSON

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Submitted herewith please find 2 sheets of drawings in compliance with 37 C.F.R. § 1.84.

The Examiner is respectfully requested to acknowledge receipt of these drawings. The submitted drawings incorporate the proposed drawing changes approved in Paper No. 8.

Respectfully submitted,

Frank L. Bernstein  
Registration No. 31,484

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Date: August 23, 2004

#### Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

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Date: August 23, 2004

Signed:   
Thea K. Wagner